

**Notice of References Cited**

Application/Control No.

10/675,140

Applicant(s)/Patent Under  
Reexamination  
GOEL ET AL.

Examiner

DANIEL C. MCCracken

Art Unit

1793

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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2002/0122754	09-2002	Ryzhkov, Vladislav Andeevitch	422/186.21
	B	US-			
	C	US-			
	D	US-			
	E	US-			
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	I	US-			
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	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Prinzbach, et al., Gas-phase production and photoelectron spectroscopy of the smallest fullerene, C <sub>20</sub> , Nature 2000; 407: 60-63
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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